



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 7, 2026	
IGI Report Number	LG835628637
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	6.49 X 6.35 X 4.20 MM

GRADING RESULTS

Carat Weight	1.58 CARAT
Color Grade	G
Clarity Grade	VVS 2

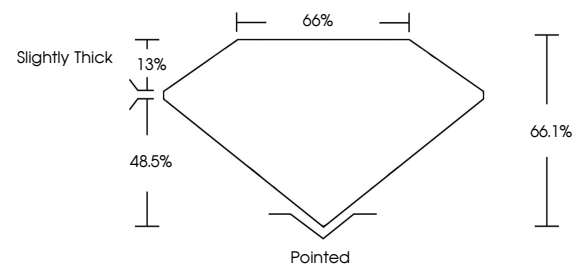
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG835628637

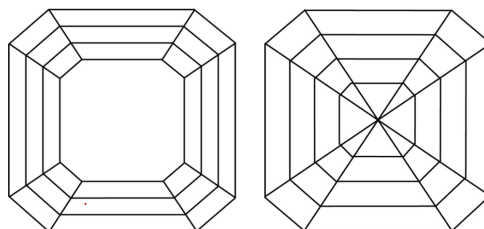
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG835628637
Report verification at iqi.org

PROPORTIONS

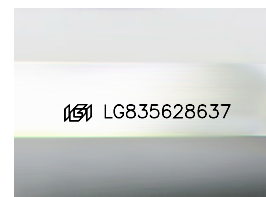


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

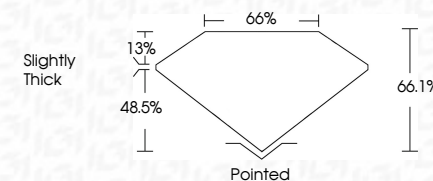
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September 7, 2026	1.58 CARAT
GL Report No. LG89269837	G
SIEMENS EMERALD CUT	VVS 2
	66.1%
	65%
	Slightly Thick
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	ISS: LG89269837

Comments:

This is a Natural Crown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA